## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Adam William Saxler et al.

Serial No.: To Be Assigned Filed: Concurrently Herewith

For: NITRIDE-BASED TRANSISTORS AND METHODS OF FABRICATION

THEREOF USING NON-ETCHED CONTACT RECESSES

Date: July 11, 2003

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Attached is a list of documents on form PTO-1449 together with a copy of each identified document. It is requested that these documents be considered by the Examiner and officially made of record in accordance with the provisions of 37 C.F.R. § 1.97 and Section 609 of the MPEP.

No fee is believed due. However, the Commissioner is hereby authorized to charge any deficiency or credit any overpayment to our Deposit Account No. 50-0220.

Respectfully submitted,

Robert M. Meeks

Registration No. 40,723



PATENT TRADEMARK OFFICE

"Express Mail" mailing label number EV 353610072 US

Date of Deposit: July 11, 2003

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to Mail Stop Patent Application, Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Candi L. Riggs

FORM PTO-1449 U.S. Department of Commerce Patent and Trademark Office  LIST OF DOCUMENTS CITED BY APPLICANT  (Use several sheets if necessary)			Attorney D	Attorney Docket Number 5308-248		Serial No. To Be Assigned
			Applicants	Applicants: Adam William Saxler et al.		
			Filing Dat	e: Concurrentl	y Herewith	Group
	U. S. F	PATENTS & PATENT	T APPLICATION PU	BLICATIONS		
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
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1	Yu et al., "Scho	CUMENTS (Including ttky barrier engineering), No. 13, September 28	g in III-V nitrides via	the piezoelecti		olied Physics
	LARCES, YOL 73,	, real to, peptember 20	, 1770, pp. 1000-100			

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